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APPLICANTS

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This application is a CON of PCT/JP02/09734 09/20/2002

** FOREIGN APPLICATIONS ***** *YF-1 LV*

JAPAN 2001-299435 09/28/2001

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35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after		DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	<i>Allowance</i> Examiner's Signature <i>LV</i>	Initials	5	24	7

ADDRESS

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TITLE

Silicon substrate etching method and etching apparatus

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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